



AFM/P

081468-0305376

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

FRANCISCUS BERNARDUS MARIA VAN  
BILSEN, ET AL.

Serial No.: 10/665,404

Filed: September 22, 2003

For: ALIGNMENT SYSTEMS AND  
METHODS FOR LITHOGRAPHIC  
SYSTEMS

Confirmation No: 4408

Art Unit: 2878

Examiner: Allen, Stephone B.

**REQUEST FOR RECONSIDERATION**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed on August 1, 2006, reconsideration of the above-identified application is respectfully requested for the following reasons:

No extension of time or other fees are believed to be due, except as detailed in the attached documents. However, any extension of time necessary to prevent abandonment is hereby requested, and any fee necessary for consideration of this response is hereby authorized to be charged to Deposit Account Number 03-3975.

**Amendments to the Claims:** none.

**Remarks:** begin on page 2 of this paper.